

46379

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Takashi FUJII et al.

Serial No.: 10/784,211

Filed: February 24, 2004

For: PROCESS FOR PRODUCING COLD

FIELD EMISSION CATHODES

Group Art Unit: 1734

Examiner: J. Sells

<u>AMENDMENT</u>

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In response to the January 27, 2006 Office Action, please amend the above-identified application as follows.